

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of :
Leslie Michael LEA et al. : Group Art Unit 1763
Serial No. 10/043,265 : Examiner Alejandro Mulero, Luz
Filed January 14, 2002 : Confirmation No. 5387
PLASMA PROCESSING APPARATUS :

**LETTER ACCOMPANYING
INFORMATION DISCLOSURE STATEMENT**

U.S. Patent and Trademark Office
E-FILING
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

On September 24, 2008, the undersigned filed an IDS together with a Certification under 37 CFR §1.97(e)(2). However, the reference cited in the IDS was contained in a communication from a foreign patent office in a counterpart foreign application, and according, the §1.97(e)(2) Certification should not have been made. This mistake was made innocently and without deceptive intent.

In consideration of the defect in the September 24th IDS noted above, submitted herewith is a substitute IDS form and a Request For Continued Examination (RCE).

It is respectfully requested that this Letter be made of record in the application.

Respectfully submitted,
Leslie Michael LEA et al.
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Date: March 25, 2009

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